

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Continuation Application of:)
Shinji TAKEDA et al.) **Atty. Docket: TM&K0008**
Serial No. _____ (based on U. S.)
Patent Application Serial No. 09/543,247,)
filed April 5, 2000))
Filed: Herewith)
For: SEMICONDUCTOR DEVICE AND)
PROCESS FOR FABRICATION) Date: February 20, 2001
THEREOF)

#2
5-2401
Payton

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D. C. 20231

Sir:

This is an Information Disclosure Statement with regard to the above-identified application. Form PTO/SB/08A is attached.

The documents cited are the closest prior art known to the applicants, and copies of the cited documents can be found in the applicant's parent U. S. Patent Application Serial No. 08/981,702. Accordingly, no further comment in regard to the disclosures of these documents is believed to be required.

It is respectfully requested that the cited documents be considered and officially cited, and that a copy of the Form PTO/SB/08A, initialed by the Examiner to indicate that the documents have been considered, be returned to the applicants.

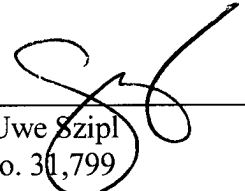
It is believed that the present Information Disclosure Statement complies with the

CON. Apln. of Serial No. 09/543,247 -2-

requirements of 37 C.F.R. §§ 1.97-8, but if a fee should be required, authorization is hereby given to deduct from deposit account No. 501281.

Respectfully submitted,

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